



**ELECTRONIC COPY**

LG646445295  
Report verification at igi.org



August 2, 2024

IGI Report Number **LG646445295**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.33 - 6.38 X 4.00 MM**

**GRADING RESULTS**

Carat Weight **1.01 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**

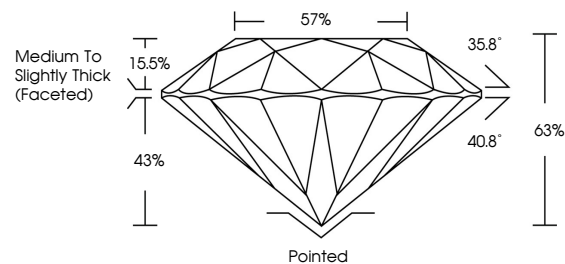
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG646445295**

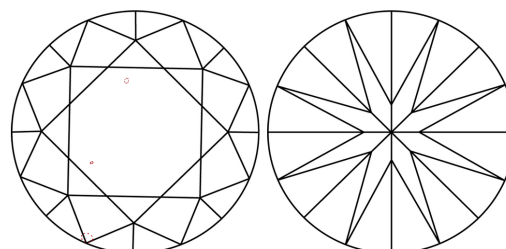
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

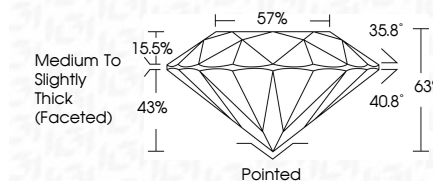
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **VERY GOOD**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



August 2, 2024  
IGI Report No LG646445295  
ROUND BRILLIANT  
6.33 - 6.38 X 4.00 MM  
Carat Weight 1.01 CARAT  
Color Grade E  
Clarity Grade VS 1  
Cut Grade EXCELLENT  
Depth 63%  
Table 57%  
Girdle Medium To Slightly Thick (Faceted)  
Culet Pointed  
Polish VERY GOOD  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG646445295  
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